



Attorney's Docket No. 042390.P16685

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Robert S. Chau, et al.

Application No. **10/749,347**

Filed: **12/30/2003**

For: **ATOMIC LAYER DEPOSITION USING PHOTO-
ENHANCED BOND RECONFIGURATION**

Examiner: **Brewster, William M.**

Art Unit: **2823**

PRELIMINARY AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

Applicants have filed a Request for Continued Examination. Applicants have amended claims 1 and 21, and cancelled claim 7. Applicants respectfully request entry of the following amendments

02/22/2006 AWONDAF1 00000059 10749347

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